
Oral presentation | 13 Semiconductors | 13.5 Semiconductor devices/ Interconnect/ Integration technologies

[11p-Z09-1~15]13.5 Semiconductor devices/ Interconnect/ Integration technologies

Gento Yamahata(NTT BRL), Munehiro Tada(NEC), Kazuhiko Endo(AIST)

Fri. Sep 11, 2020 12:45 PM - 5:15 PM Z09

△ : Presentation by Applicant for JSAP Young Scientists Presentation Award

▲ : English Presentation

▼ : Both of Above

No Mark : None of Above

2:00 PM - 2:15 PM

[11p-Z09-4][The 11th Silicon Technology Division Award Speech] Charge Pumping Under Spin Resonance in Si(100) Metal- Oxide-Semiconductor Transistors

○Masahiro Hori¹, Yukinori Ono¹ (1.Shizuoka Univ.)

Keywords:interface defect, charge pumping, EDMR